

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of Applicants:

Date: July 13, 2009

Haight et al.

Group Art Unit: 3742

Serial No.: 09/933,461

Examiner: Geoffrey S. Evans

Filed: August 20, 2001

Docket No.: YOR919980510US2

For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF  
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTIONS DATED 02/24/2009 and 06/18/2009**

Amendments to the claims begin on 2 page of this paper.

Remarks begin on 20 page of this paper.